

Search Notes



Application/Control No.

10/780,291

Examiner

José V. Chen

Applicant(s)/Patent under Reexamination

RASMUSSEN ET AL.

Art Unit

3637

SEARCHED

Class	Subclass	Date	Examiner
108	51.11 51.3	3/16/06	JVC
	56.1		
	56.13		
	57.16		
	57.17		
	57.18		
	57.19		
	57.21		
	57.22		
	57.23		
	57.3.		
	57.32		

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

SEARCH NOTES (INCLUDING SEARCH STRATEGY)

	DATE	EXMR
Pat & Back Cit Pat Part Art 7	3/17/06	JVC